



ALICE ITS3

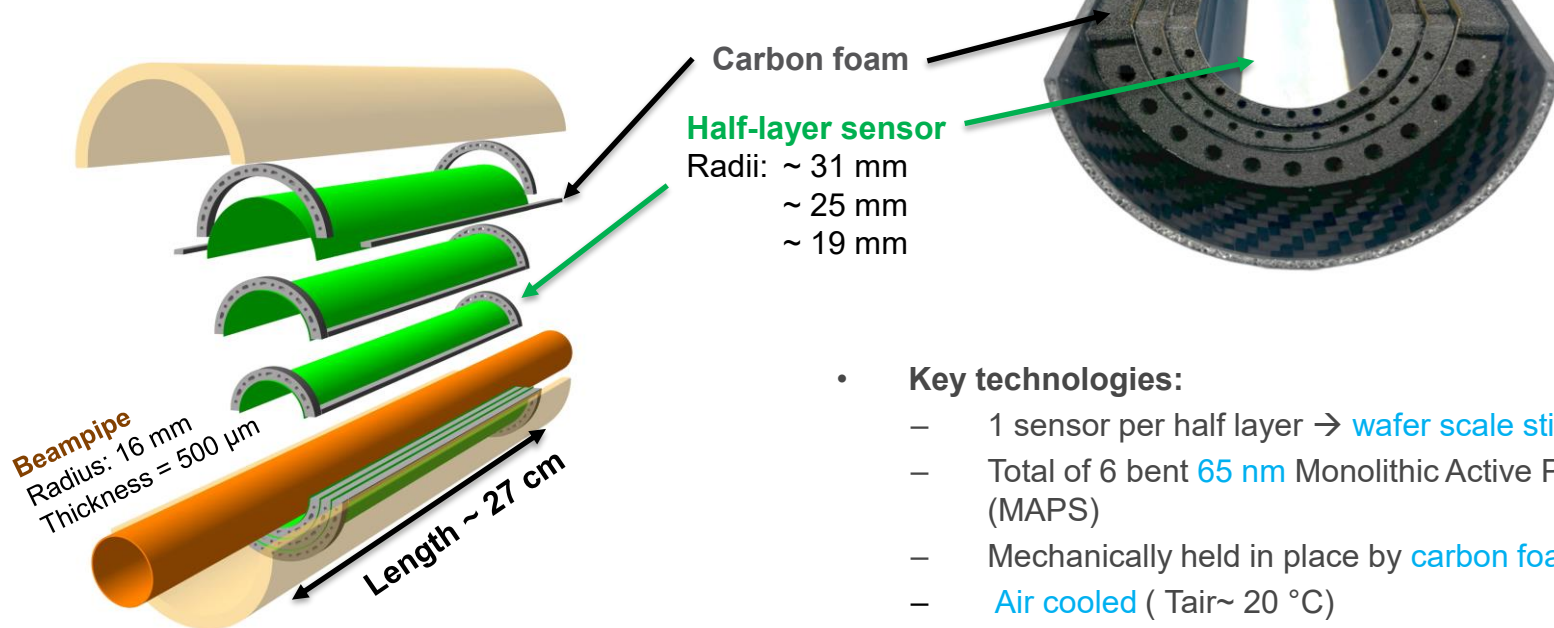
Status Report 2024-2025

P. La Rocca

NB: Info and plots from ITS3 Plenary meetings, WP meetings, conference talks, ...

Inner Tracking System (ITS3)

- ITS2 → ITS3: 3 innermost layers replaced
- **Basic idea:** minimize material budget (0.09 % X_0) and distance to interaction point



- **Key technologies:**
 - 1 sensor per half layer → **wafer scale stitched**
 - Total of 6 bent **65 nm** Monolithic Active Pixel Sensors (MAPS)
 - Mechanically held in place by **carbon foam ribs**
 - **Air cooled** ($T_{\text{air}} \sim 20^\circ\text{C}$)

ITS3 Project Organization

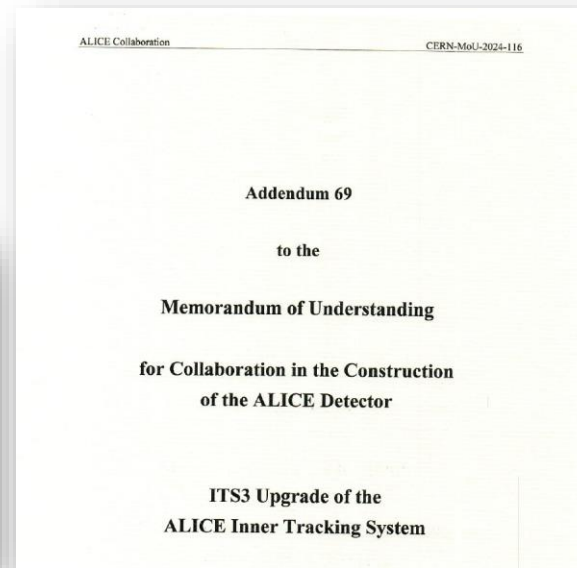


ITS3 Milestones



LOI = Letter of Intent
MLR1 = Multi Layer Reticle
ER = Engineering Run
TDR = Technical Design Report
QM = Qualification Model

MOU INFN-CERN signed in Jan 2025 (CD res. n. 17303)



MOU: Costs, Contributions and Responsibilities

01.07.24	2024	2025	2026	2027	2028	Total
	C&I	C&I	C&I	C&I	C&I	C&I
Total	1470	1671	480	100	180	3901
CMOS Sensor ASIC						2280
CMOS Sensor Fabrication	900	900				1800
Sensor Characterisation	180	150				330
Thinning/Dicing & Bending/Interconnect	75	75				150
Integration						930
Mechanics, Assembly & Test	100	150	100			350
Installation & Alignment	50	50	100	100		300
Air cooling	50	50				100
Installation & comissioning infrastructure					180	180
Readout Electronics						431
Common readout unit (CRU)		70				70
Detector Service Electronics (DSE)	40	50	100			190
Optical cables	5	6	30			41
Flexible Printed Circuit	70	60				130
Power Distribution						210
Power Supplies & Regulation		50				50
Power Cables		60	100			160
DCS (Detector control system)			50			50

Annex 5: Contributions and Responsibilities

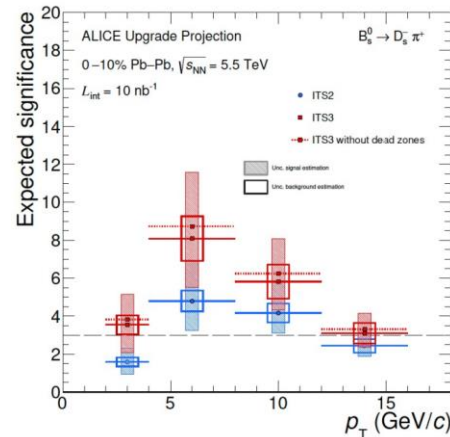
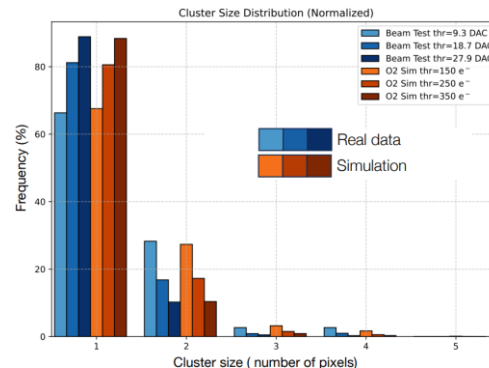
03.07.24	CERN	CZ	FR	IT	KR	NL	NO	SE	SK	TH	Total
Funding (kCHF)											
ITS3 C&I	947	145	420	850	284	660	250	245	80	20	3901
CMOS Sensor ASIC											
CMOS Sensor Fabrication	X	X	X	X	X	X	X	X			
Sensor Characterisation	X	X	X	X	X	X	X	X		X	
Thinning/Dicing & Bending/Interconnect	X			X	X						
Integration											
Mechanics, Assembly & Test	X			X							
Installation & Alignment	X										
Air cooling	X										
Installation & comissioning infrastructure	X		X	X							
Readout Electronics											
Common readout unit (CRU)			X	X			X				
Detector Service Electronics (DSE)			X	X		X	X				
Optical cables				X							
Flexible Printed Circuit	X		X	X		X					
Power Distribution											
Power Supplies & Regulation			X	X							
Power Cables				X							
DCS	X								X		
Physics performance & reconstruction	X		X	X							
Commissioning	X	X	X	X	X	X	X	X	X	X	

Table 5.2: Field of responsibilities of contributors for the ALICE ITS3 upgrade describing the technical involvement of contributor person power.

WP1: Physics, simulation and reconstruction

WP1: Physics, simulation and reconstruction

- Conveners: **A. Rossi**, F. Grosa
- Great effort in the preparation of the TDR
 - Detector layout
 - Heavy-flavour physics studies
 - Hypernuclei and c-deuteron
 - Strangeness tracking
- A good summary in: [TDR CERN-LHCC-2024-003](#) and [ALICE-PUBLIC-2023-002](#)
- Complete ITS3 geometry implemented in the ALICE O2 framework
- New simulations with detailed geometry and precise dead zones inclusion done
- Realistic chip's response implemented
- **ITS3 WP1 meeting merged with ITS2 software (WP2) meeting** (from July 2024)



WP2: Pixel Sensor ASIC design and **WP3: Sensor Characterisation and Qualification**

WP2: Pixel Sensor ASIC design and WP3: Sensor Characterisation and Qualification

INFN Contribution (BA, BO, CA, CT/ME, PD, TO, TS)

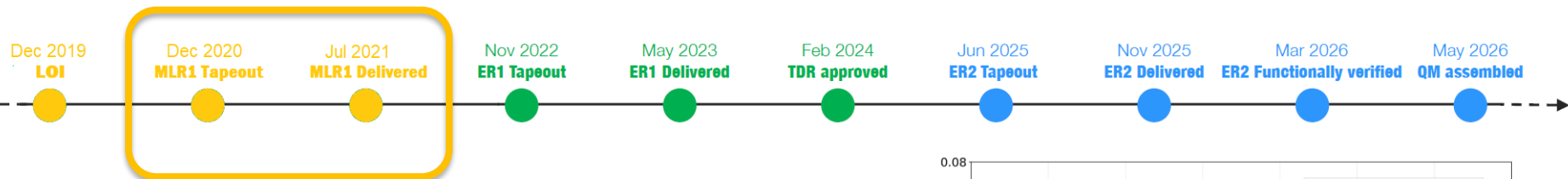
- Contribution to sensor design
- Contribution to sensor fabrication (330 kEUR in 2024, 110.5 in 2025 + 39.5 kEUR anticipated in 2024)
- Development of test systems (hardware and software)
- Sensor glueing and bonding
- Characterization of prototypes:
 - Distributed effort (several prototypes to be characterized)
 - Local lab measurements
 - Participation to testbeam and data analysis
 - Papers preparation
- Human resources:
 - INFN simifellows
 - PhD students, master students
 - Long-term presence at CERN...



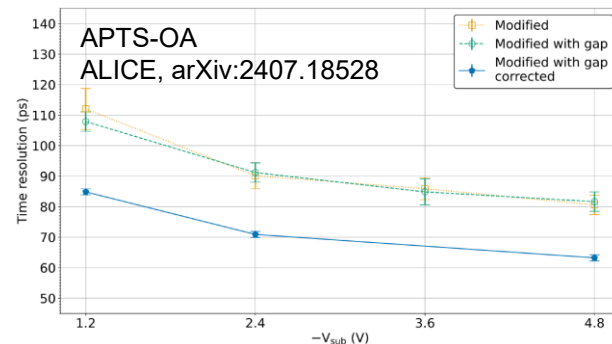
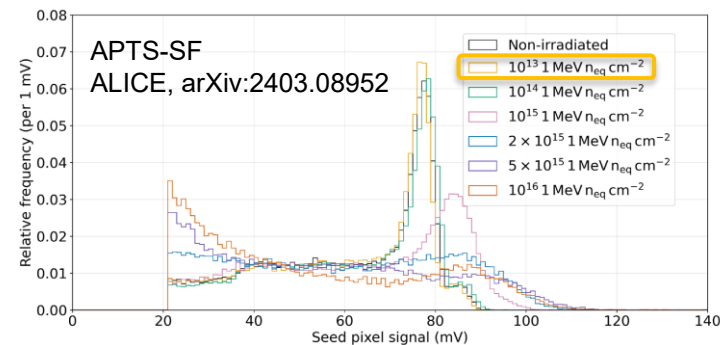
Sensor roadmap



MLR1 (Multi Layer Reticle 1): qualification of the 65 nm CMOS



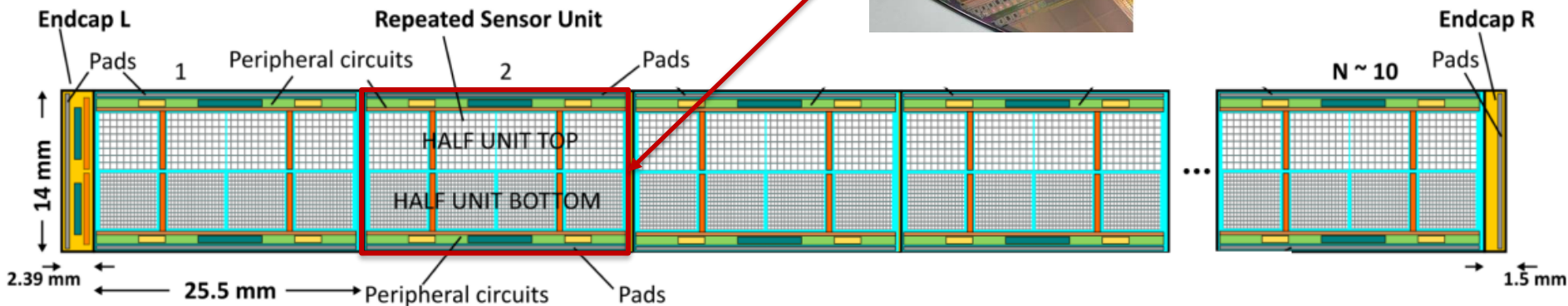
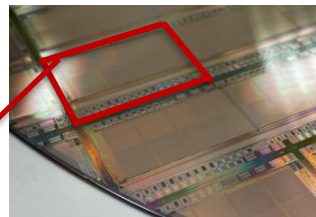
- Technology explored **beyond ITS3 requirements**:
 - Charge detection
 - Radiation hardness
- Several prototype sensors characterized
- INFN contribution**: development of MLR1 test set-up, characterization of Analog (APTS) and Digital (DPTS) Test Structures
- Papers** (INFN people in paper committees):
 - DPTS: <https://doi.org/10.1016/j.nima.2023.168589>
<https://arxiv.org/abs/2505.05867>
 - APTS-SF: <https://doi.org/10.1016/j.nima.2024.169896>
 - APTS-OA: <https://doi.org/10.1016/j.nima.2024.170034>



ER1 (Engineer Run 1): first stitched MAPS



- First stitched MAPS
- First large-area prototypes
- Stitching validation



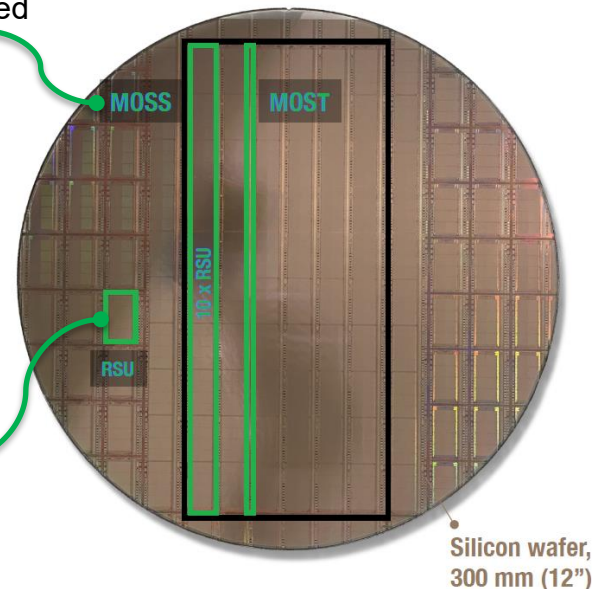
ER1 (Engineer Run 1): first stitched MAPS



- Extensive tests on **MOSS** and **baby-MOSS**
- Yield, uniformity and performances established and reliable
→ fundamental for next submission design (ER2)
- BabyMOSS contains a single RSU:
 - Suitable for irradiation purposes
 - Suitable for distribution
 - Suitable for testbeam campaign

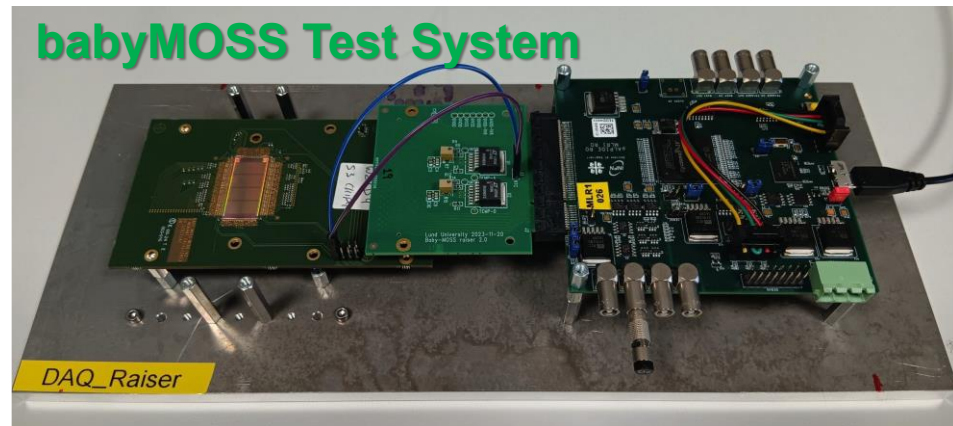
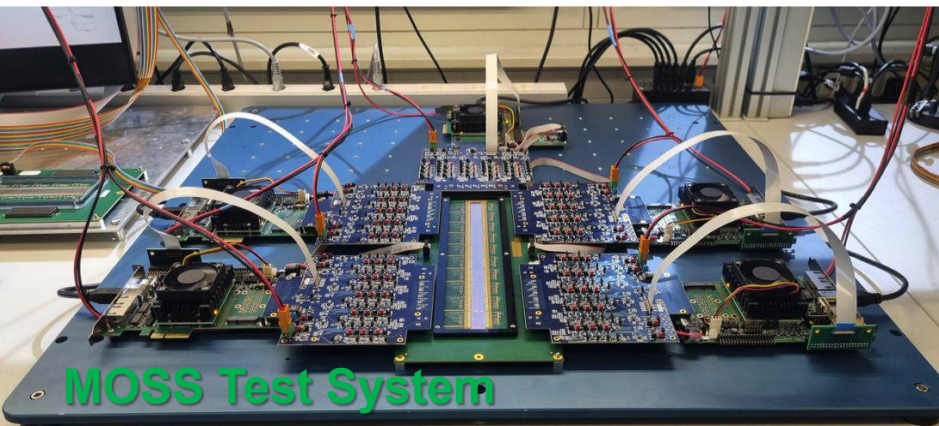
Primarily tested
@CERN

Distributed effort
(INFN contribution)



ER1 (Engineer Run 1): first stitched MAPS

Dec 2019 **LOI** Dec 2020 **MLR1 Tapeout** Jul 2021 **MLR1 Delivered** Nov 2022 **ER1 Tapeout** May 2023 **ER1 Delivered** Feb 2024 **TDR approved** Jun 2025 **ER2 Tapeout** Nov 2025 **ER2 Delivered** Mar 2026 **ER2 Functionally verified** May 2026 **QM assembled**

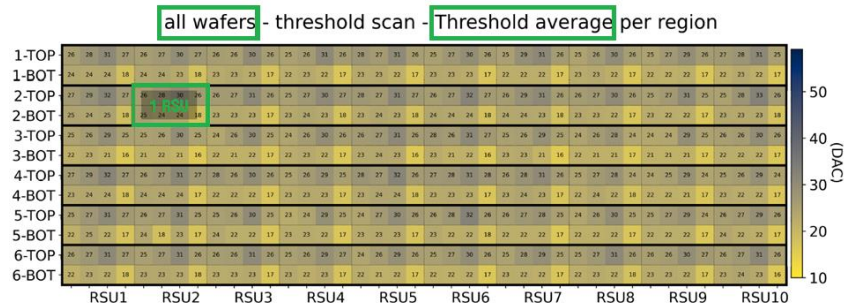


ER1 (Engineer Run 1): first stitched MAPS



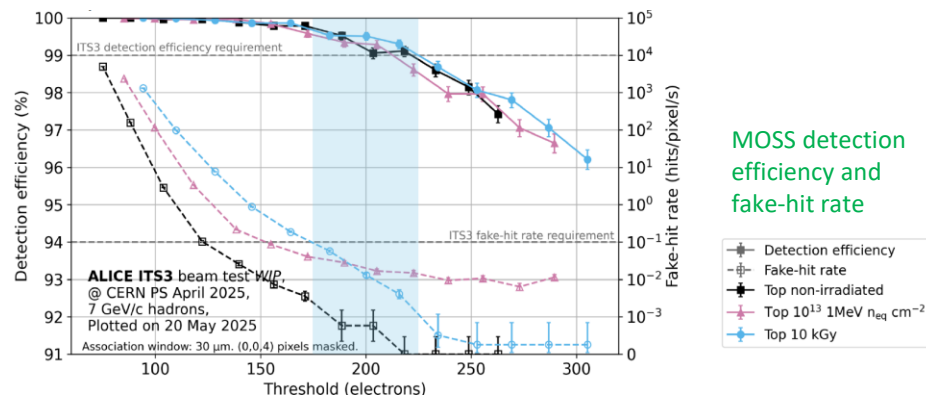
MOSS - functional tests

- Several functional tests on all 82 MOSS
 - Yield ~89 % (~98% excluding readout issues)
- Good performance and uniform behavior
 - NO wafer or sensor position dependence



Beam test results

- Operational margin à confirmed performance from previous submissions



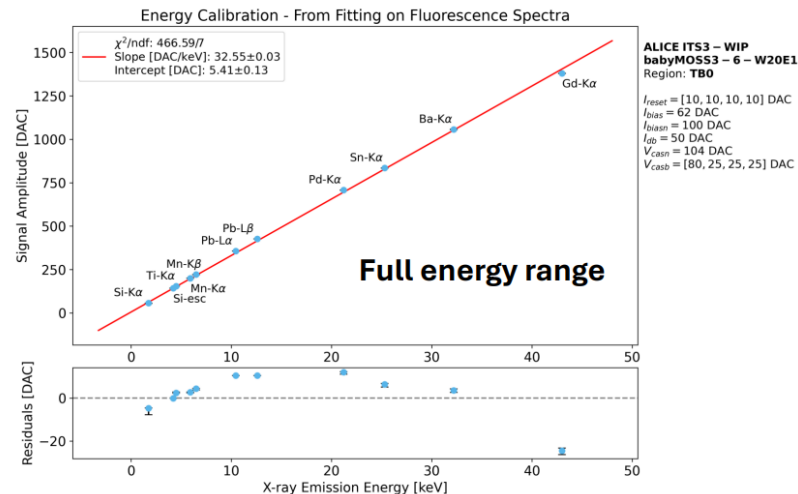
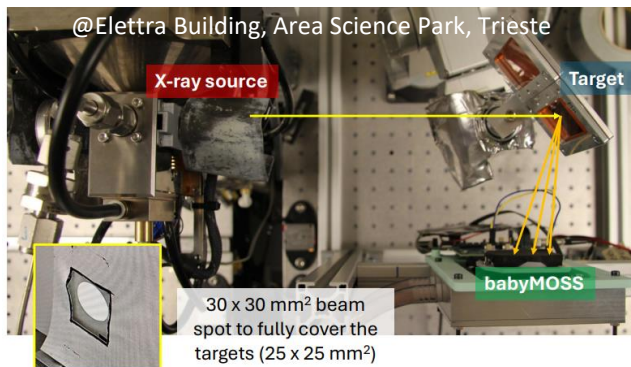
MOSS detection efficiency and fake-hit rate

ER1 (Engineer Run 1): first stitched MAPS



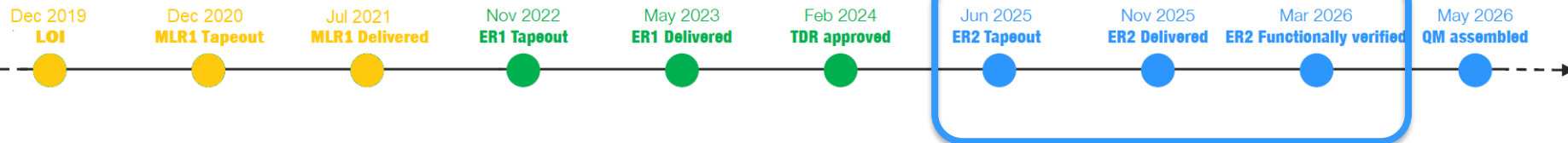
babyMOSS – Laboratory test

- Distributed characterization work
- Optimization of the FE settings
- Study of FHR, noise, threshold...
- Energy calibration (ToT) with X-ray sources + fluorescence targets





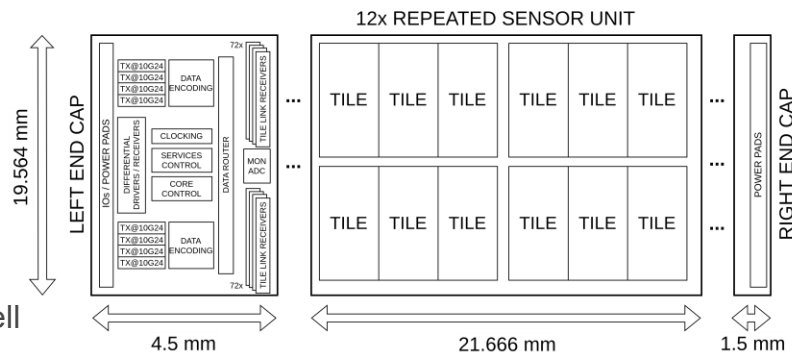
ER2 (Engineer Run 2): full size, full functionality sensor



MOSAIX: Final size 2D stitched sensor

- 12 RSU
- Each RSU is divided in turn in 12 fully independent tiles (powering, control and readout)
 - Different pixel variants for operational margins
- **Final ER2 submission → July 2025**
- **Very tight schedule** for MOSAIX testing
- Test system (hardware, firmware and software) to be ready well before chips arrive

+ CHIPLETS





ALICE

ER2 (Engineer Run 2): full size, full functionality sensor

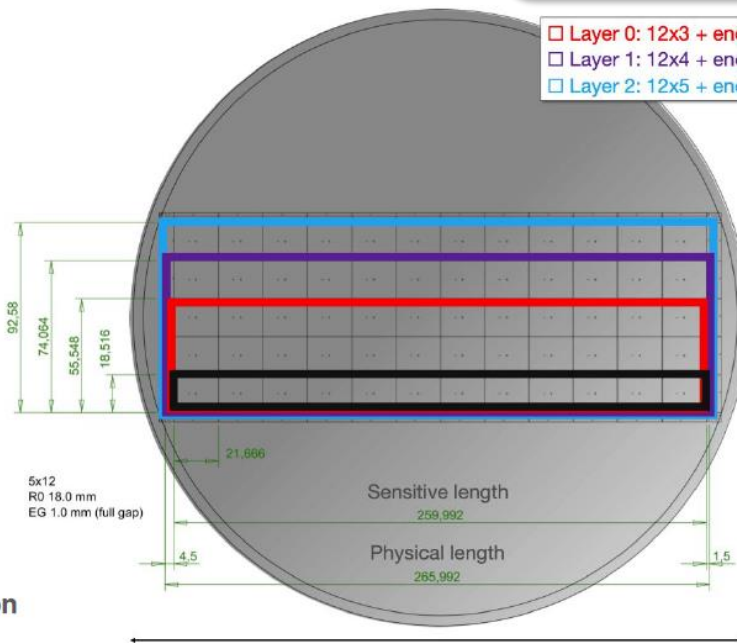


WAFER TO LAYERS

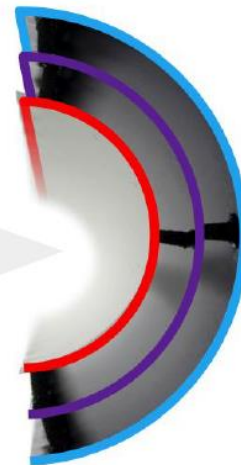
- Modular design:**
each sensor is divided into 3, 4, or 5 segments with 12 RSUs



ER2 production



Thinning
(50 μm)
&
Dicing
&
Bending





ALICE

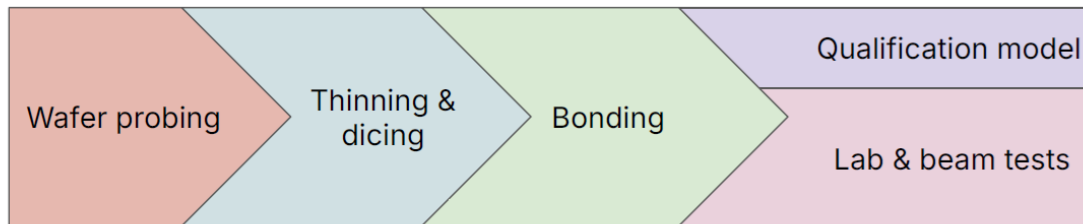
ER2 (Engineer Run 2): full size, full functionality sensor

Dec 2019 **LOI** Dec 2020 **MLR1 Tapeout** Jul 2021 **MLR1 Delivered** Nov 2022 **ER1 Tapeout** May 2023 **ER1 Delivered** Feb 2024 **TDR approved** Jun 2025 **ER2 Tapeout** Nov 2025 **ER2 Delivered** Mar 2026 **ER2 Functionally verified** May 2026 **QM assembled**

TESTING SCENARIOS



ER2 production



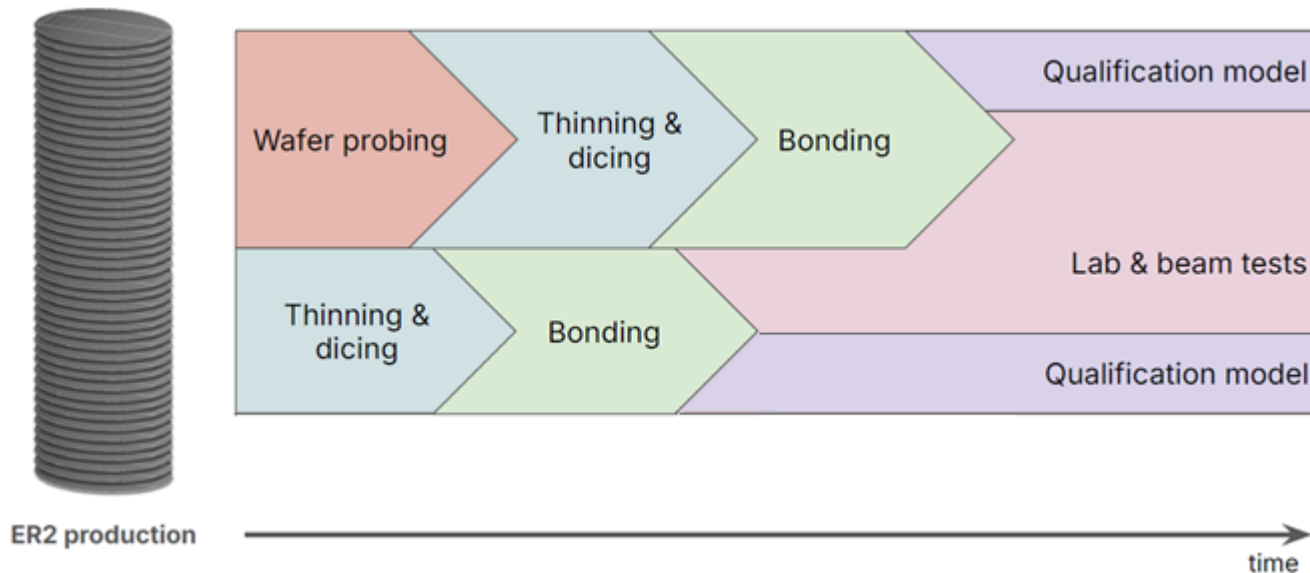


ALICE

ER2 (Engineer Run 2): full size, full functionality sensor

Dec 2019 **LOI** Dec 2020 **MLR1 Tapeout** Jul 2021 **MLR1 Delivered** Nov 2022 **ER1 Tapeout** May 2023 **ER1 Delivered** Feb 2024 **TDR approved** Jun 2025 **ER2 Tapeout** Nov 2025 **ER2 Delivered** Mar 2026 **ER2 Functionally verified** May 2026 **QM assembled**

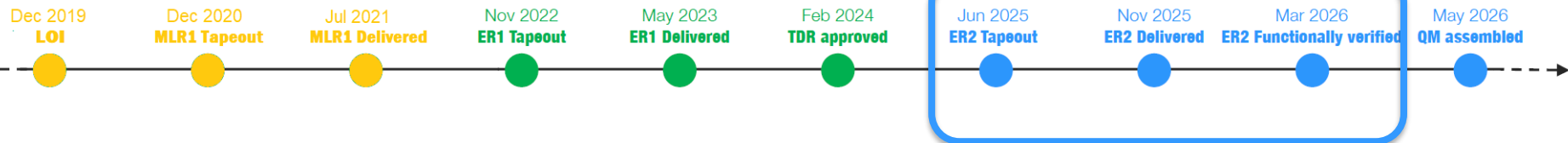
TESTING SCENARIOS



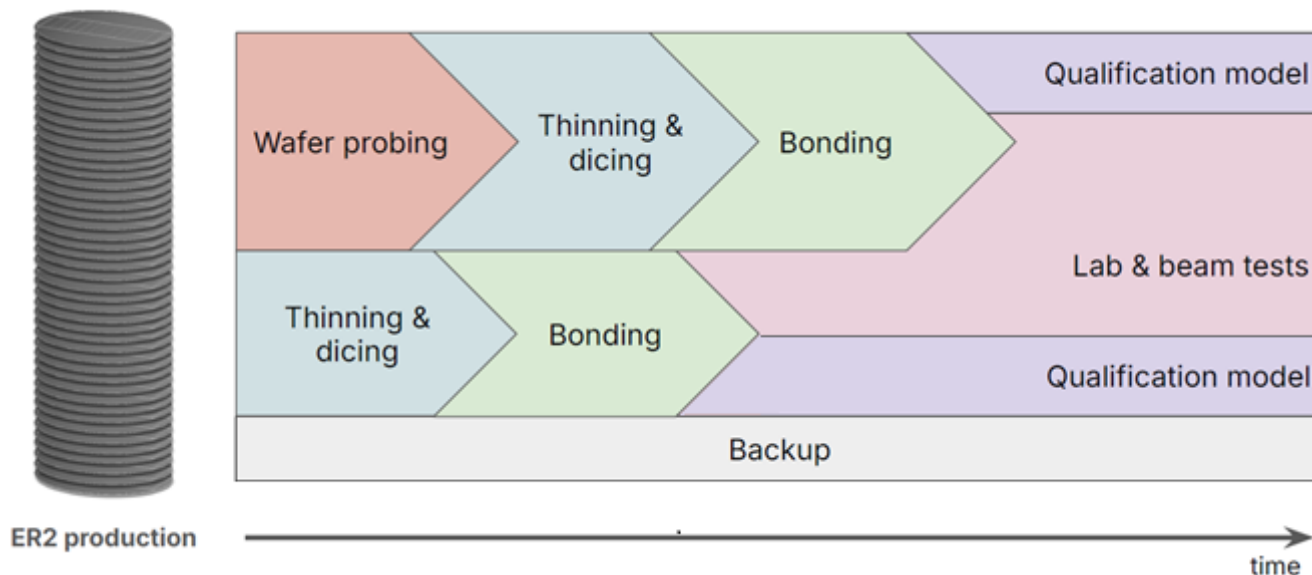


ALICE

ER2 (Engineer Run 2): full size, full functionality sensor



TESTING SCENARIOS



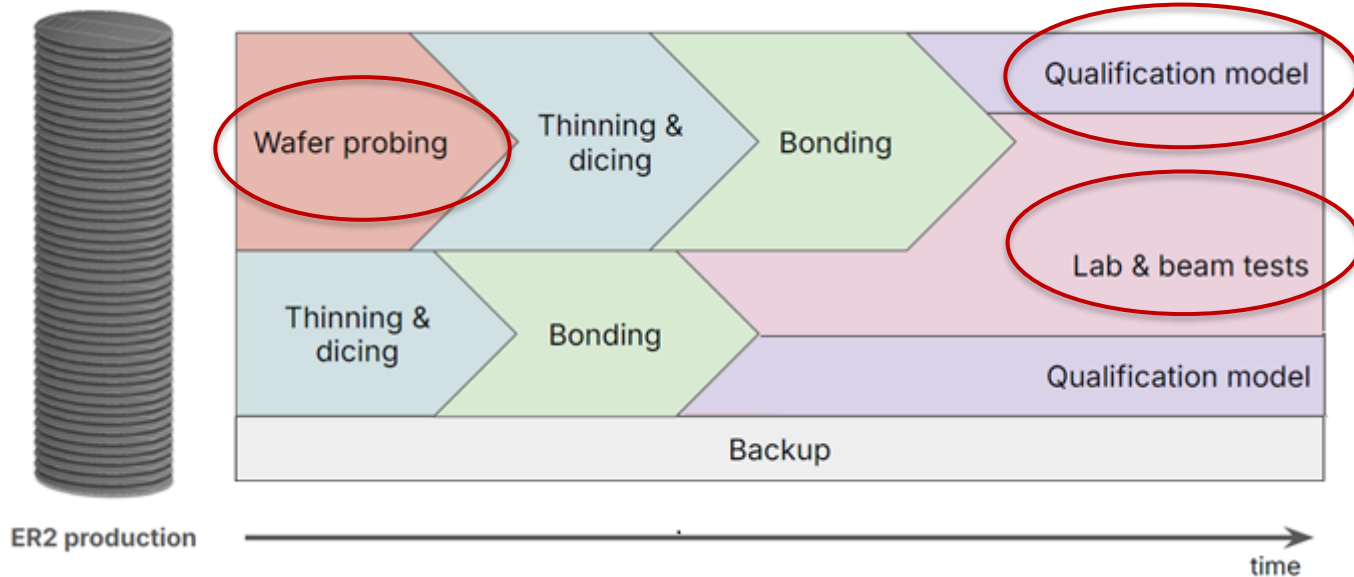


ALICE

ER2 (Engineer Run 2): full size, full functionality sensor



TESTING SCENARIOS





ALICE

ER2 (Engineer Run 2): full size, full functionality sensor

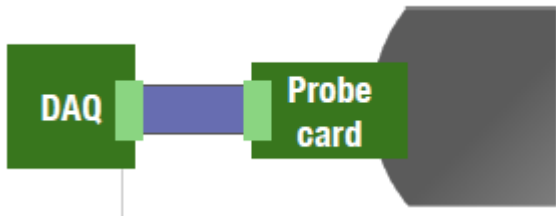


TESTING SCENARIOS

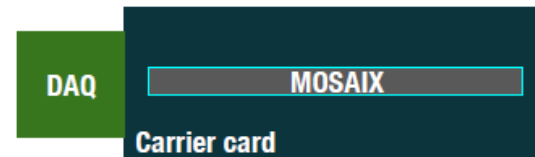
1) MOSAIX emulator → ready!



2) Wafer probing → with different needle probe cards



3) Lab & beam tests → with options of sensor sizes and connections (e.g. FPC) → **distributed effort**



4) Qualification model → test of ITS3 layers

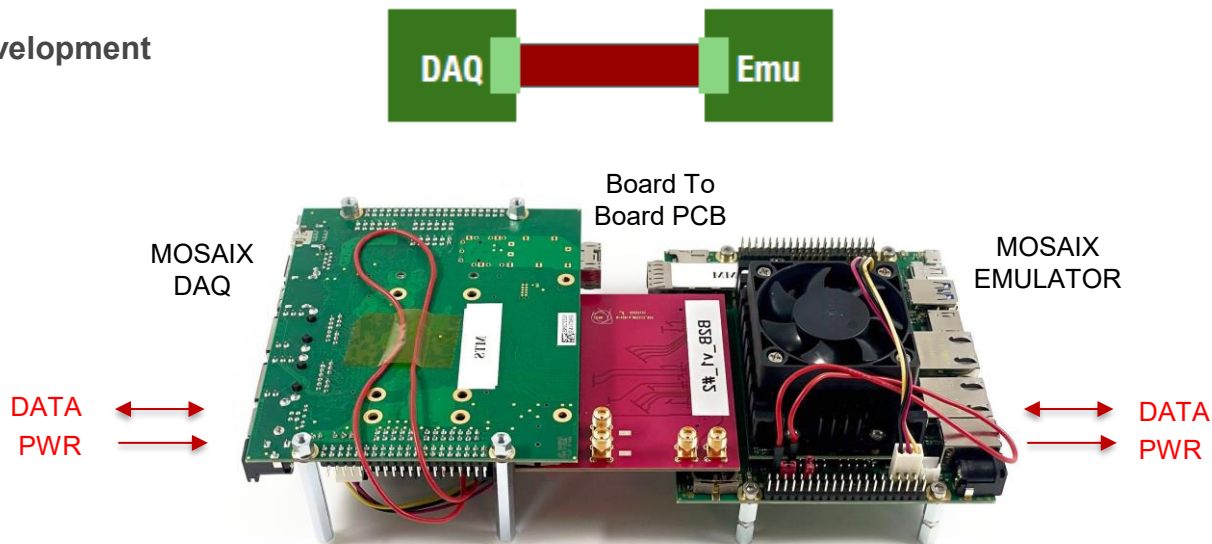


ER2 (Engineer Run 2): full size, full functionality sensor



MOSAIX EMULATOR

- Useful for HW/SW/FW **development** and testing
- **Training** tool for real chip characterization





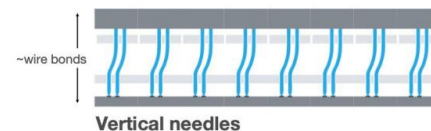
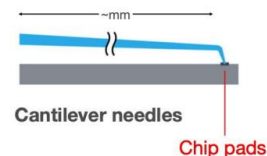
ALICE

ER2 (Engineer Run 2): full size, full functionality sensor



WAFER PROBING

- Facilities at CERN PH Department Silicon Facility
- 2 probe systems, to be re-tested with ER2 pad wafer
- Different needle probe cards



Feature	MOSAIX HS (cantilever)		MOSAIX HS (vertical)		NKF7 (vertical)	
	Status	Target date	Status	Target date	Status	Target date
Design	Done	-	Ongoing	TBA	Done	-
Design validation	Done	-	Ongoing	TBA	Done	-
Production	Done	-	Not started	August	Done	-
Commissioning	Not started	End of May	Not started	August	Done	-
		✗ 5-10 Gbps			✓ 5-10 Gbps	✓ 5-10 Gbps

ER2 (Engineer Run 2): full size, full functionality sensor

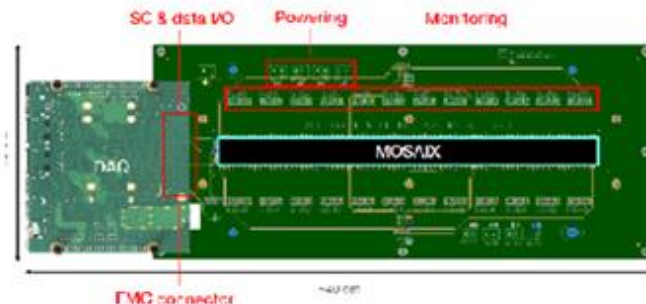
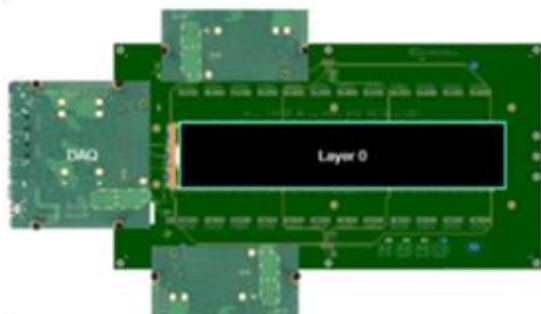


LAB & BEAM TESTS

- INFN sites are being equipped with the setup to test the babyMOSAIX (+ emulator)
- Crucial contribution given the tight timeline for the ER3 submission

babyMOSAIX (1 RSU + ECs)

- Much more per wafer
- Much easier to pick
- Several sites practiced with babyMOSS
- Same test system as MOSAIX
- Ideal for distributed characterization



ER2 (Engineer Run 2): full size, full functionality sensor

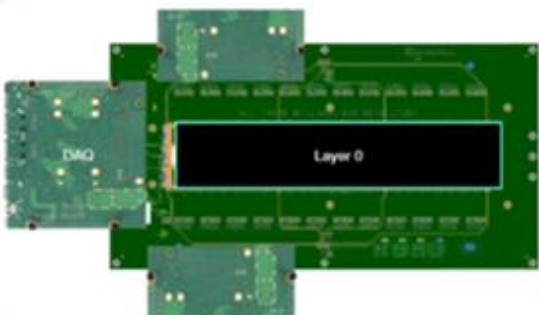


LAB & BEAM TESTS

- INFN sites are being equipped with the setup to test the babyMOSAIX (+ emulator)
- Crucial contribution given the tight timeline for the ER3 submission

babyMOSAIX (1 RSU + ECs)

- Much more per wafer
- Much easier to pick
- Several sites practiced with babyMOSS
- Same test system as MOSAIX
- Ideal for distributed characterization



RICHIESTA 2026:
 59k€ per partecipazione a beam tests
 14k€ per trasporti
 60k€ per sensore CMOS



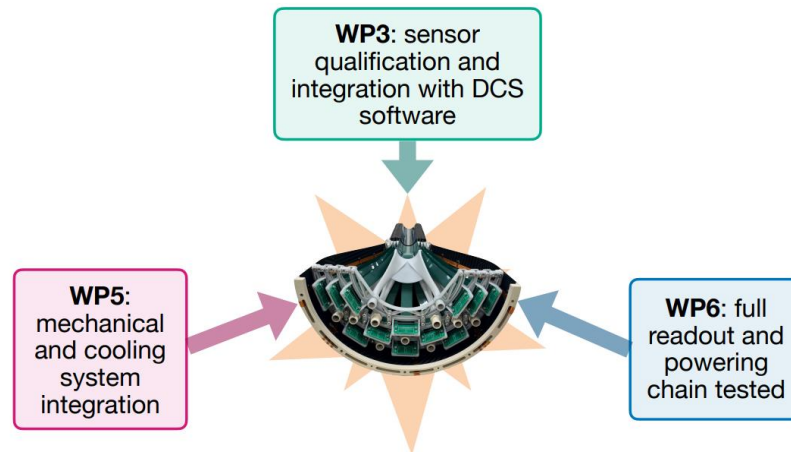
ALICE

ER2 (Engineer Run 2): full size, full functionality sensor



QUALIFICATION MODEL (QM)

- Validate the integration and functionality of all ITS3 components under realistic operating conditions
- Identify and resolve **integration**-related issues before final production and installation
- Detailed step-by-step plan and derivables defined
- 2 QMs will be produced
- A **unified effort** among different Work Packages
- **Key INFN contribution** to the development of testing systems and QM



WP4: Thinning, Bending, Interconnection and **WP5: Mechanics and cooling**

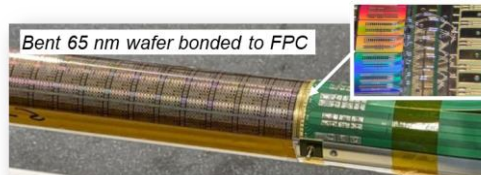
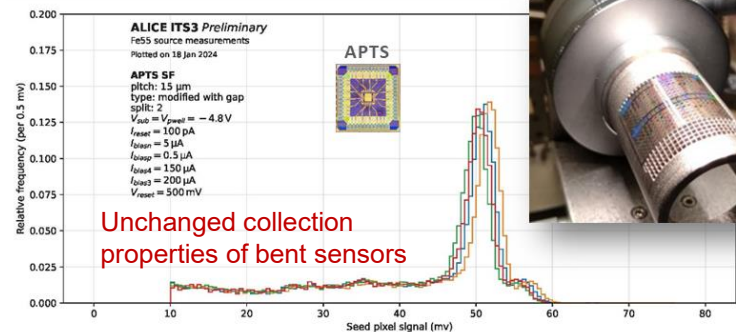
WP4: Thinning, Bending, Interconnection and **WP5: Mechanics and cooling**

- Conveners WP4: **D. Colella, G. Contin**

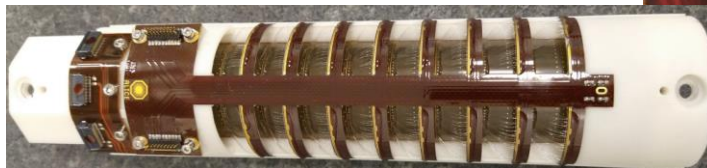


Bending MAPS (past)

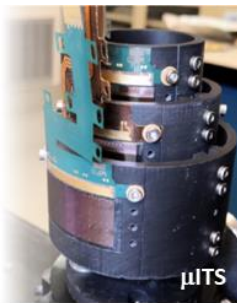
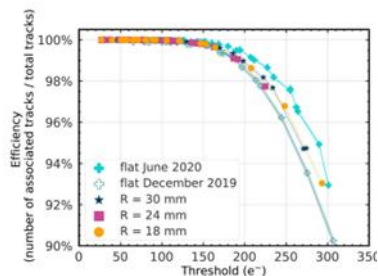
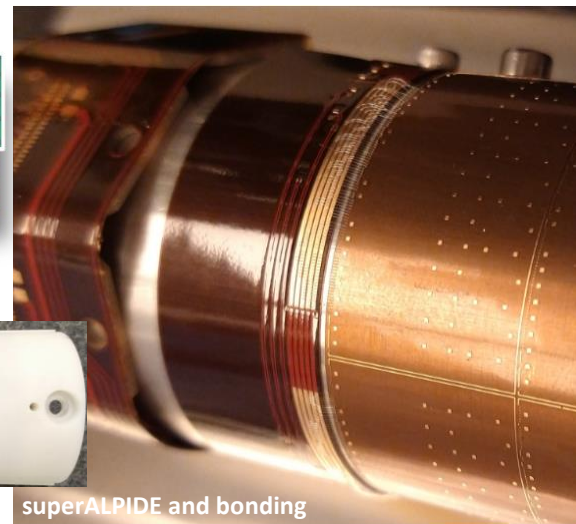
- Bending MAPS sensors (WP4)
 - Silicon becomes flexible below 50 μm thickness
 - Bend existing MAPS sensors (ALPIDE) and small test structures
 - Measure the bent sensor performance and compare with flat sensors
- R&D carried out within INFN:
 - Bending mechanics and procedures
 - Curvature precision measurements
 - Wire-bonding on curved surface
 - Laboratory characterization
 - In-beam performance measurements



superALPIDE + eskeloton



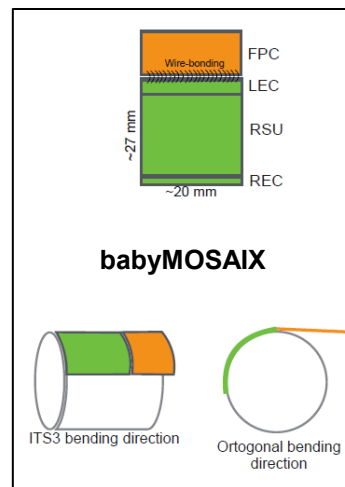
superALPIDE and bonding



Bending MAPS (future)

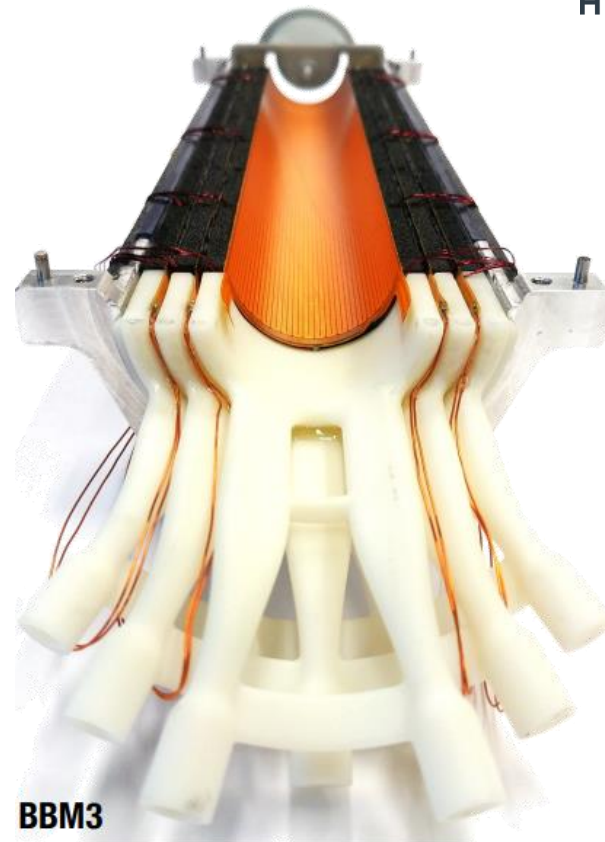
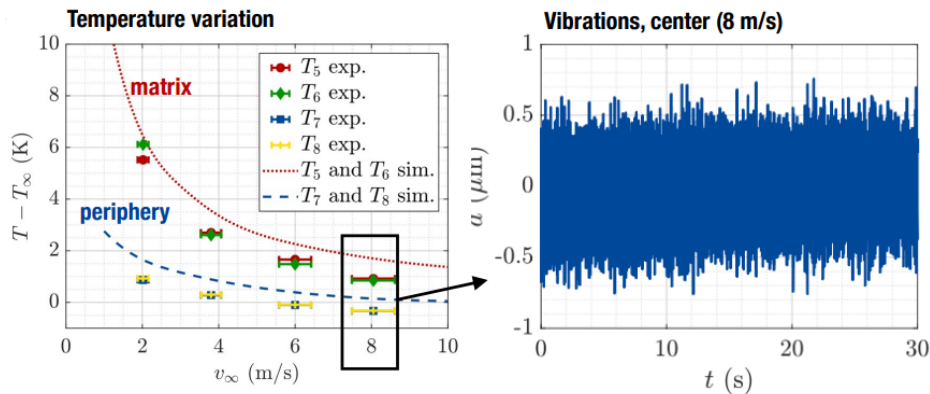
Bending large area sensors:

- babyMOSS
 - First effort started in 2024
 - Challenge: wire bonding on all 4 sides → Flexible PCB
 - Work ongoing
- MOSS
 - Difficulties in handling and bending single segment
 - Under evaluation
- babyMOSAIX
 - Useful for lab testing, testbeam with telescope, study of ageing through thermal cycles
- MOSAIX
 - Qualification Models (mainly @CERN)
- INFN interest in baby sensor bending activities



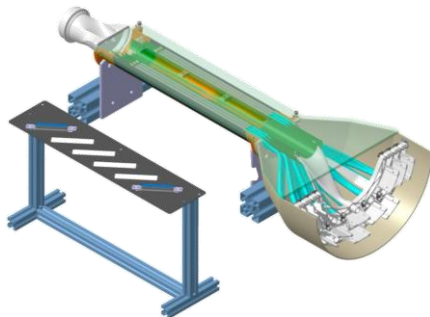
Mechanics – Bread Board Models

- Prototypes for air cooling
- Thermal and stability test:
 - Several Bread Board Models based on heating elements with carbon foam support structure
 - Placed in a custom wind tunnel, thermal and mechanical properties studied (BBM3)

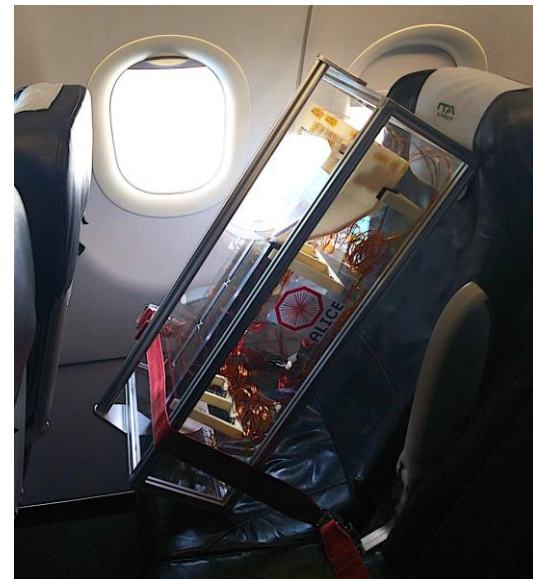


Mechanics – Bread Board Models

- New **BBM6 done in Bari**, now at CERN for integration in an upgraded wind tunnel
 - closer design to final
 - improved heaters design
 - improved mapping and temperature precision
- **Next INFN activity:** study of wire bond strength under air flow conditions
 - Realization of a wind tunnel, equipped with flow meters
 - Assembly of the prototype: bent sensors + FPC
 - Wire bonding and pull-force measures



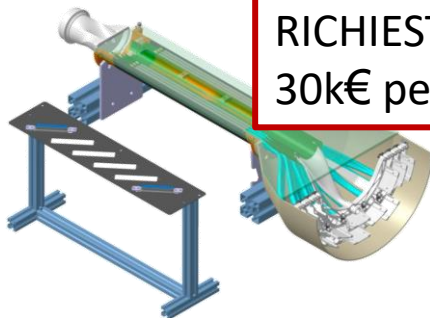
Stack-up [μm]	
PU protection	10
Copper	5
Kapton	12.5
Silicon	40
Kapton	12.5
Glue	10
Total thickness 110-120 μm	



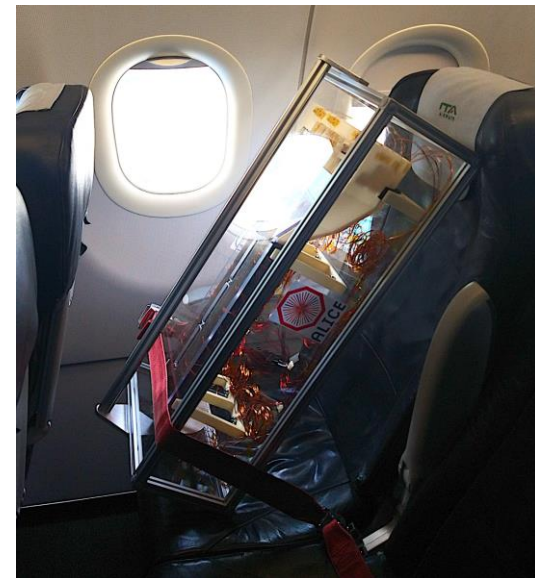
Mechanics – Bread Board Models

- New **BBM6 done in Bari**, now at CERN for integration in an upgraded wind tunnel
 - closer design to final
 - improved heaters design
 - improved mapping and temperature precision
- **Next INFN activity:** study of wire bond strength under air flow conditions
 - Realization of a wind tunnel, equipped with flow meters
 - Assembly of the prototype: bent sensors + FPC
 - Wire bonding and pull-force measures

Stack-up [μm]	
PU protection	10
Copper	5
Kapton	12.5
Silicon	40
Kapton	12.5
Glue	10
Total thickness 110-120 μm	



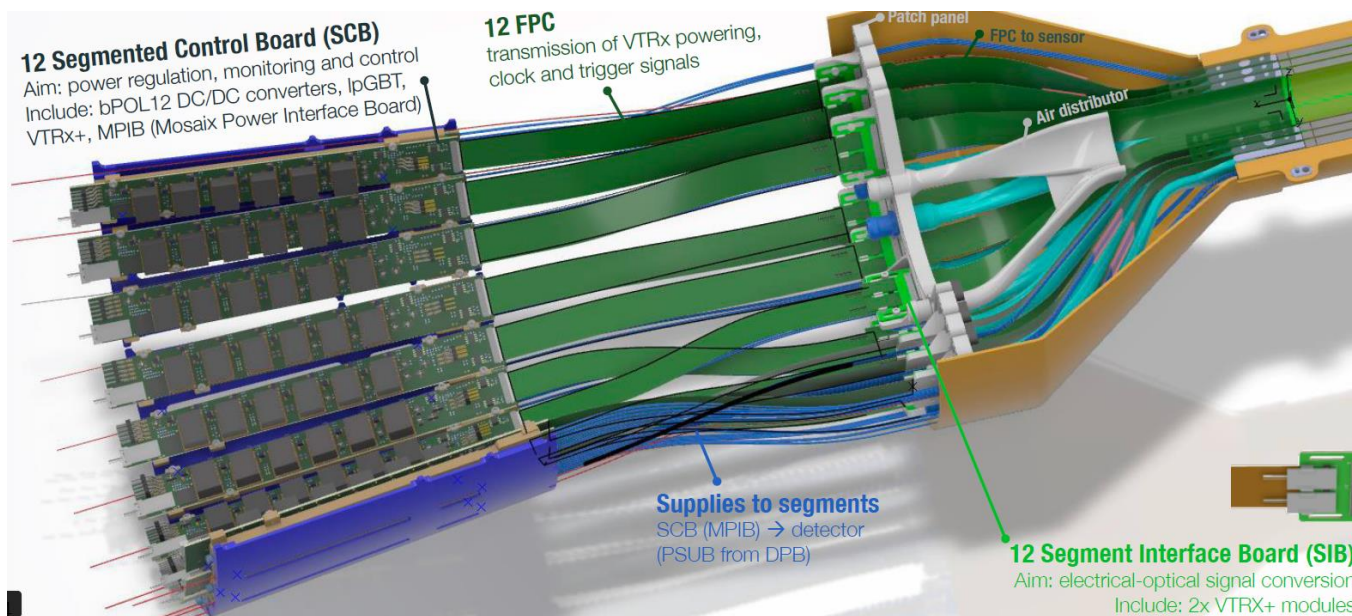
RICHIESTA 2026:
30k€ per attività WP5



WP6: Readout electronics, Power Supply and Services

WP6: Readout electronics, Power Supply and Services

- Conveners: **S. Siddhanta**, **P. Giubilato**, O. Bourrion
- Full scale model realization ongoing



WP6: Readout electronics, Power Supply and Services

Detector Service Boards

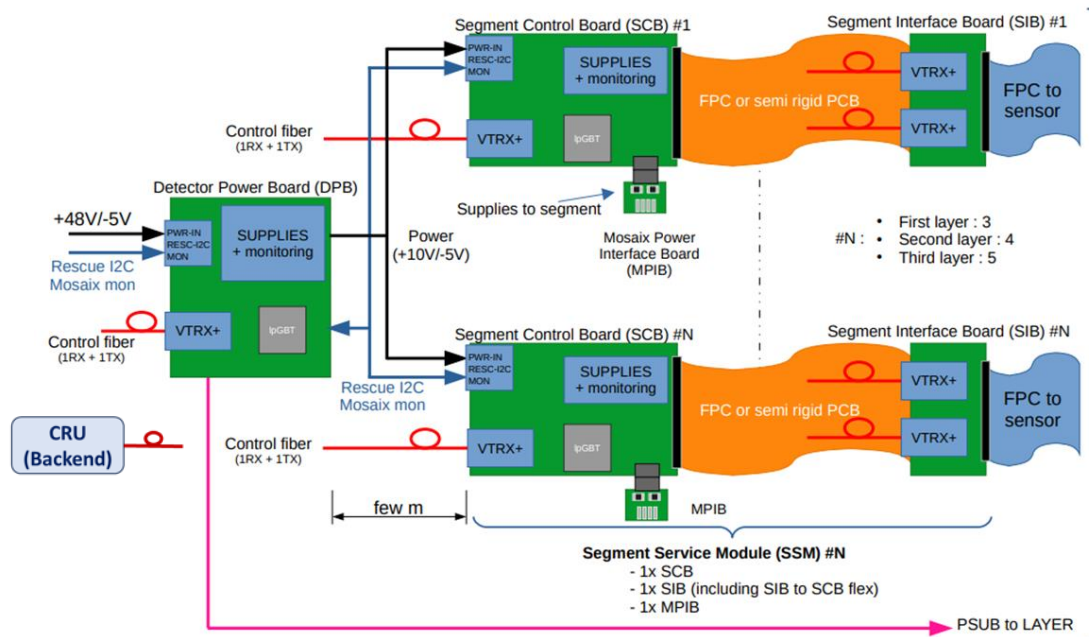
- Design of the boards done at Grenoble
- First prototypes produced, **tests started**
- INFN will participate in the test and qualification as part of full system tests
- 2 testbenches (CERN and PD)

Common Readout Unit (CRU)

- CRU common logic is a central development
- ITS3 will have a new User Logic
- INFN (CA and PD) is involved in the User Logic development

Qualification model:

- Cross WP development
- Will integrate all the final WP components
- Study integration issues
- Study WP6 component performance and qualify them in realistic settings



WP6: Readout electronics, Power Supply and Services

Detector Service Boards

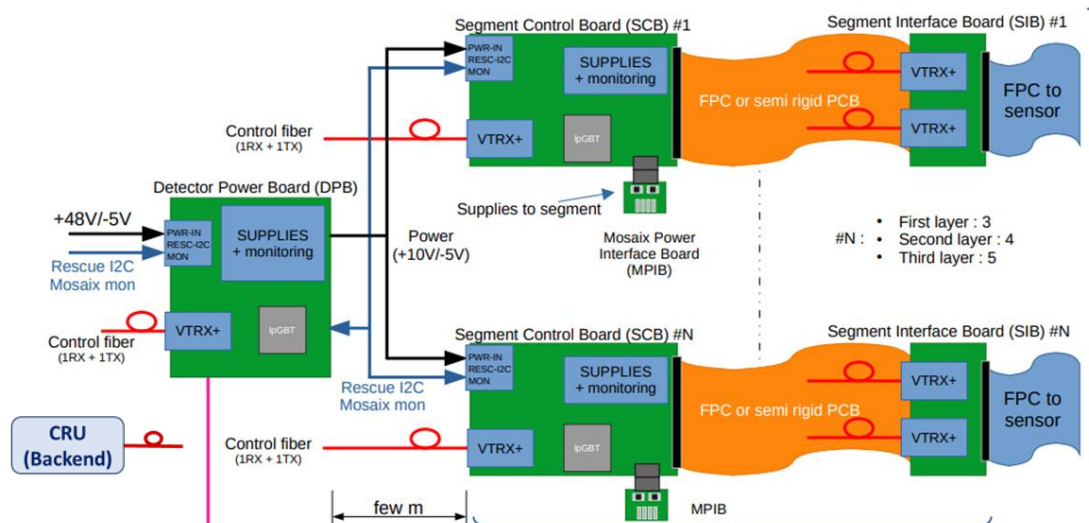
- Design of the boards done at Grenoble
- First prototypes produced, **tests started**
- INFN will participate in the test and qualification as part of full system tests
- 2 testbenches (CERN and PD)

Common Readout Unit (CRU)

- CRU common logic is a central development
- ITS3 will have a new User Logic
- INFN (CA and PD) is involved in the User Logic development

Qualification model:

- Cross WP development
- Will integrate all the final WP components
- Study integration issues
- Study WP6 component performance and qualify them in realistic settings

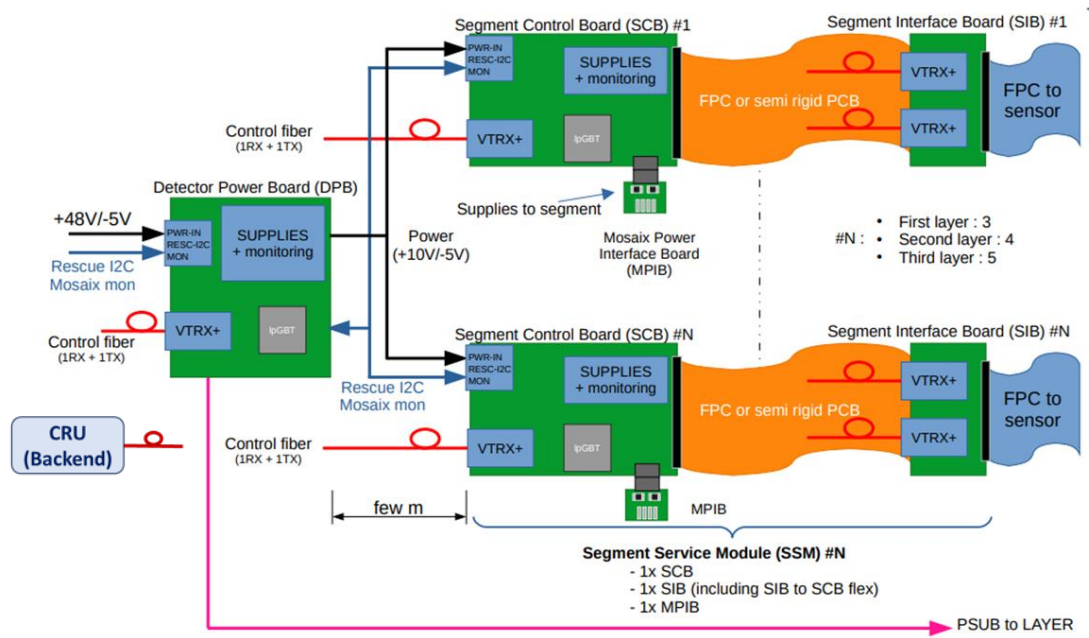


RICHIESTA 2026:
 18k€ per n.3 CRU (WP6)
 30k€ + 6k€ per missioni CERN

WP6: Readout electronics, Power Supply and Services

Flexible Printed Circuit (FPC)

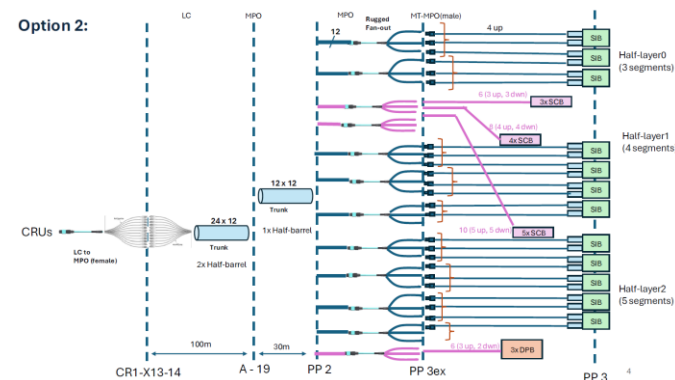
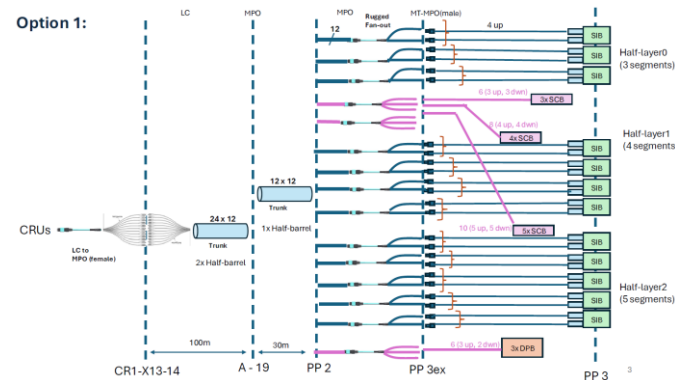
- Layout of a single segment is replicated multiple times depending on the layer
- Bonded on the sensor
- Design of FPC done at CERN, INFN (TS) involved in the characterization of FPC
- FPC prototype received, assembling the test system



WP6: Readout electronics, Power Supply and Services

Optical Fibers

- Under **INFN responsibility**
- Fragile elements → several optical link schemes under investigation
- Final choice based on mock-up evaluation
- The cost depends on the the total fiber length
- Some fibers are custom-made

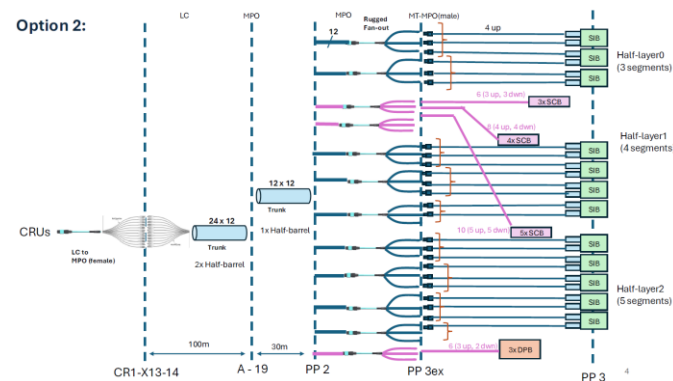
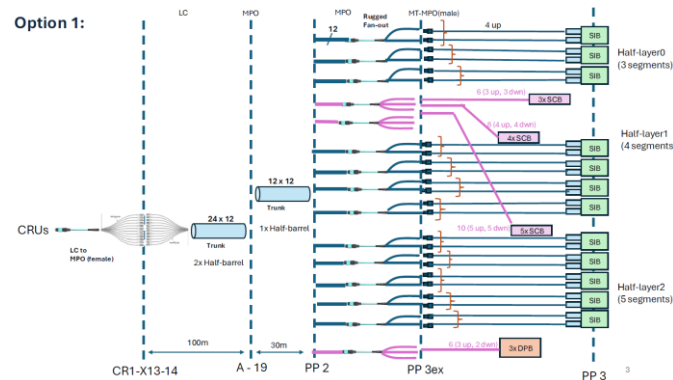


WP6: Readout electronics, Power Supply and Services

Optical Fibers

- Under **INFN responsibility**
- Fragile elements → several optical link schemes under investigation
- Final choice based on mock-up evaluation
- The cost depends on the total fiber length
- Some fibers are custom-made

RICHIESTA 2026:
40k€ per optical fibers



WP6: Readout electronics, Power Supply and Services

POWER SUPPLIES

PSUB -5V to DPB

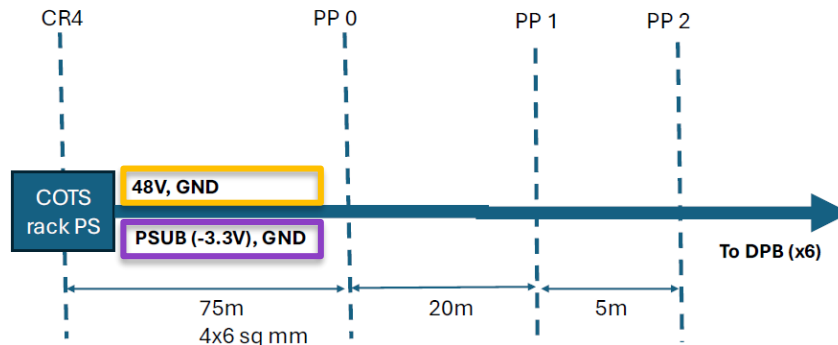
- CAEN A2518 – Obsolete but spares available from ITS2
- Alternative – CAEN 2551

48V to DPB

- CAEN A2554 – a new model received for tests
- Given the characteristics, we can use A2554 also for PSUB

LV cable integration study accomplished and first samples arrived

Under INFN responsibility



WP6: Readout electronics, Power Supply and Services

POWER SUPPLIES

PSUB -5V to DPB

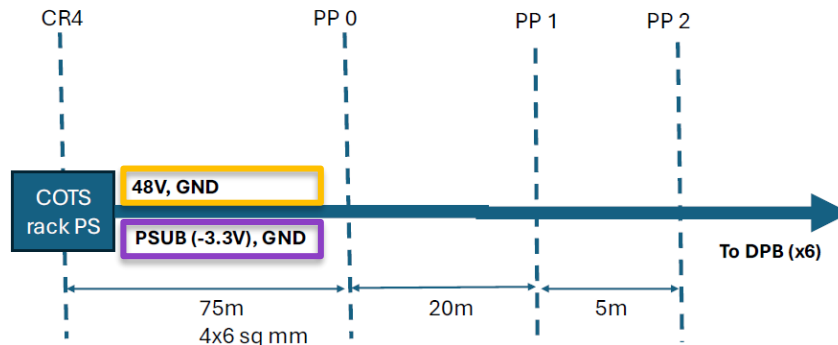
- CAEN A2518 – Obsolete but spares available from ITS2
- Alternative – CAEN 2551

48V to DPB

- CAEN A2554 – a new model received for tests
- Given the characteristics, we can use A2554 also for PSUB

LV cable integration study accomplished and first samples arrived

Under INFN responsibility



RICHIESTA 2026:
25k€ per power supplies

Financial requests 2026

Capitolo	Descrizione	Importo (kEUR)	Sede
Apparati	ITS3 CORE: contributo a meccanica	30	BA
Apparati	ITS3 CORE: acquisto 3 CRU (18keuro) + Optical cables (40keuro) + Power Supplies (25keuro)	83	CA
Apparati	ITS3 core: contributo alla produzione, caratterizzazione, thinning e dicing del sensore CMOS	60*	CT
Missioni	Partecipazione Beam Tests	59	BA/CT/LNF/PD/TO/TS
Missioni	Richiesta specifica per attività WP6 al CERN	30	CA
Missioni	Richiesta specifica per attività WP6 al CERN	6	PD
Trasporti	ITS3: spedizioni schede, chip ed assemblati	14	BA/CA/CT/LNF/PD/TO/TS
TOTALE		282 (di cui 173 CORE)	

*60 kEUR chiesti per il 2025 ma NDB

Funding plan overview

tipo attività	2021 (k€)	2022 (k€)	2023 (k€)	2024 (k€)	2025 (k€)	2026 (k€)	2027 (k€)	totale richiesta INFN (k€)	totale ITS3 (k€)
R&D	200	300	150 WP3=100 WP4+5=50					700	2500
Costruzione CORE (assegnato)			ER2: 250	350* (340)	300 (200.5 + 39.5**)	100 +70	100	1100***	3901 (MOU)
Totale								1800	6400
Viaggi			50	50	70	95			

* 65k€ richiesta straordinaria a settembre 2024

** 39.5 k€ anticipati nel 2024

*** di cui 850 k€ secondo MOU

In grassetto voci aggiornate

Milestones 2024

		Data prevista per il completamento	Descrizione	Completamento al 30.06.2024 (%)	Commenti al 30.06.2024	Completamento al 31.12.2024 (%)	Commenti al 31.12.2024
4	ITS3	30/6/2024	ITS3 1: Partecipazione a beam test con sensori stitched	100	Risultati confermano i buoni risultati di efficienza di rivelazione ottenuti in test beam su test structures di piccola area. Altri test sono previsti nel corso dell'anno per completare la caratterizzazione	100	
5	ITS3	31/12/2024	ITS3 2: verifica performance sensore stitched curvato	30	Ricevuti mandrini high quality e piegato wafer non funzionante	80	Test sui sensori stitched curvati in fase di sviluppo, la verifica delle performance è stata ritardata a seguito del prolungarsi dei test sui sensori stitched planari
6	ITS3	31/12/2024	ITS3 3: Invio alla fonderia del sensore stitched a grande area versione ER2	40	Disegno validato, ottimizzazioni finali in corso, alla luce di problemi rilevati durante i test su sensori MOSS (ER1)	80	Design del sensore ormai definito, in corso processi di verifica e ottimizzazione, con l'identificazione e la correzione di bug

Milestones 2024

		Data prevista per il completamento	Descrizione	Completamento al 30.06.2024 (%)	Commenti al 30.06.2024	Completamento al 31.12.2024 (%)	Commenti al 31.12.2024
4	ITS3	30/6/2024	ITS3 1: Partecipazione a beam test con sensori stitched	100	Risultati confermano i buoni risultati di efficienza di rivelazione ottenuti in test beam su test structures di piccola area. Altri test sono previsti nel corso dell'anno per completare la caratterizzazione	100	100 %: bonding and bending procedure finalised. Performance studies on ER2 sensors
5	ITS3	31/12/2024	ITS3 2: verifica performance sensore stitched curvato	30	Ricevuti mandrini high quality e piegato wafer non funzionante	80	Test sui sensori stitched curvati in fase di sviluppo, la verifica delle performance è stata ritardata a seguito del prolungarsi dei test sui sensori stitched planari
6	ITS3	31/12/2024	ITS3 3: Invio alla fonderia del sensore stitched a grande area versione ER2	40	Disegno validato, ottimizzazioni finali in corso, alla luce di problemi rilevati durante i test su sensori MOSS (ER1)	80	Design del sensore ormai definito, in corso processi di verifica e ottimizzazione, con l'identificazione e la correzione di bug

Milestones 2024

		Data prevista per il completamento	Descrizione	Completamento al 30.06.2024 (%)	Commenti al 30.06.2024	Completamento al 31.12.2024 (%)	Commenti al 31.12.2024
4	ITS3	30/6/2024	ITS3 1: Partecipazione a beam test con sensori stitched	100	Risultati confermano i buoni risultati di efficienza di rivelazione ottenuti in test beam su test structures di piccola area. Altri test sono previsti nel corso dell'anno per completare la caratterizzazione	100 100 %: bonding and bending procedure finalised. Performance studies on ER2 sensors	~100% imminent submission (July 2025)
5	ITS3	31/12/2024	ITS3 2: verifica performance sensore stitched curvato	30	Ricevuti mandrini high quality e piegato wafer non funzionante	80	Test sui sensori stitched curvati in fase di sviluppo, la verifica delle performance è stata ritardata a seguito del prolungarsi dei test sui sensori stitched planari
6	ITS3	31/12/2024	ITS3 3: Invio alla fonderia del sensore stitched a grande area versione ER2	40	Disegno validato, ottimizzazioni finali in corso, alla luce di problemi rilevati durante i test su sensori MOSS (ER1)	80	Design del sensore ormai definito, in corso processi di verifica e ottimizzazione, con l'identificazione e la correzione di bug

Milestones **2025**

		Data prevista per il completamento	Descrizione	Completamento al 30.06.2025 (%)	Commenti al 30.06.2025	Completamento al 31.12.2025 (%)	Commenti al 31.12.2025
ITS 3	26	31/3/2025	Validazione sistema readout	20	Ricevuti i primi prototipi, test di validazione iniziati		
ITS 3	27	31/12/2025	Prima caratterizzazione di sensori MOSAIX	20	Sottomissione ER2 posticipata in base a nuova schedula LHC e arrivo dei sensori prevista a fine 2025. Sistemi di test validati e in fase di distribuzione		

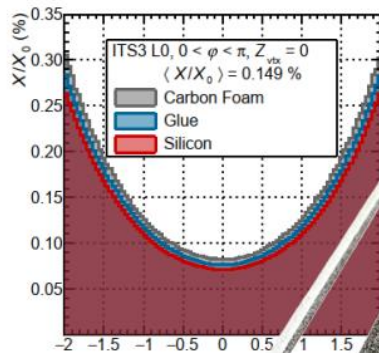
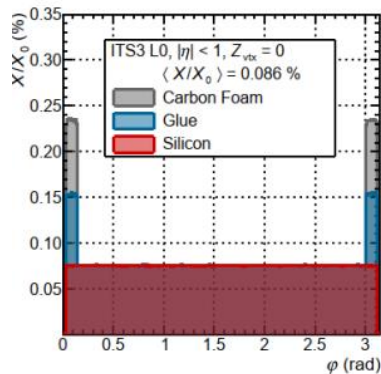
Milestones **2026**

		Data prevista per il completamento	Descrizione	Completamento al 30.06.2026 (%)	Commenti al 30.06.2026	Completamento al 31.12.2026 (%)	Commenti al 31.12.2026
ITS 3		31/12/2026	Verifica resistenza bonding soggetto a flusso d'aria				
ITS 3		31/12/2026	Realizzazione Qualification Model				
ITS 3		31/12/2026	Definizione e prima implementazione della User Logic della CRU				
ITS 3		31/03/2026	Definizione schema fibre ottiche e scelta alimentatori				
ITS 3		31/12/2026	Caratterizzazione di sensori MOSAIX				



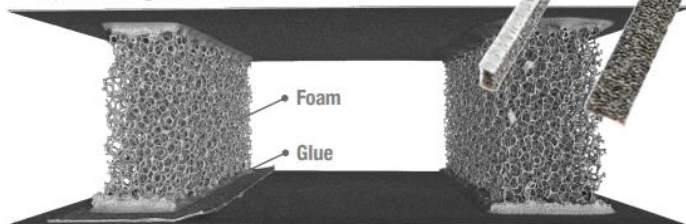
Backup slides

Mechanics – Carbon Foam



Open-cell carbon foam spacers

- Support and cooling optimization, maintaining the low material budget
- Improved for glue amount and distortion



Longerons
(ERG Duocel Carbon)

Half-ring
(ERG Duocel Carbon)

Half-ring
(Allcomp K9 SD)
(High Thermal conductivity)



Mechanics – Engineering Model (EM)

Prototypes for layout, assembly and installation procedures validation

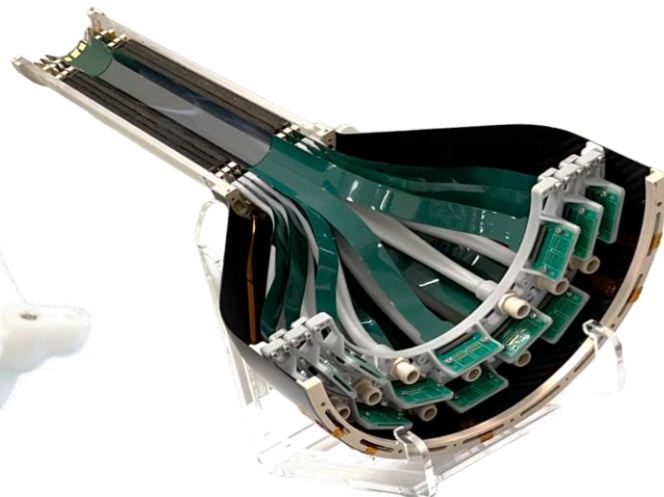
- 3 Ems completed + EM4 ongoing



EM1



EM2

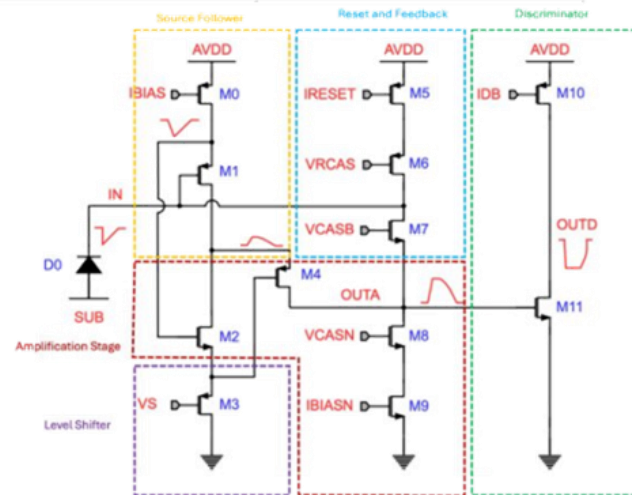


EM3

MOSS Region variations

	Region 0	Region 1	Region 2	Region 3
TOP	Standard	Larger input transistor (M1)	Larger discriminator input transistor (M11)	Larger common-source transistor (M2)
BOTTOM	Standard	Standard	Standard	Slightly different layout

- Top region 1: Larger M1
 - less $1/f$ noise → less noisy pixels at larger thresholds
 - larger input C → worse S/N
- Top region 2: Larger L of M11
 - smaller threshold dispersion
 - larger capacitance OUTA → lower gain → worse S/N
- Top region 3: Larger W of M2
 - larger gain
 - Could push M1 out of saturation
- Bottom region 3: Smaller feedback capacitance
 - larger gain
 - more ringing



MOSS – testing campaign

Before picking and bonding on carrier:

- ▶ **Wafer-probing**

In laboratory, 3 main steps:

- ▶ **Impedance** tests between power nets
- ▶ **Power ramp** (slowly by domain)
- ▶ **Functional tests**

In **beam test**:

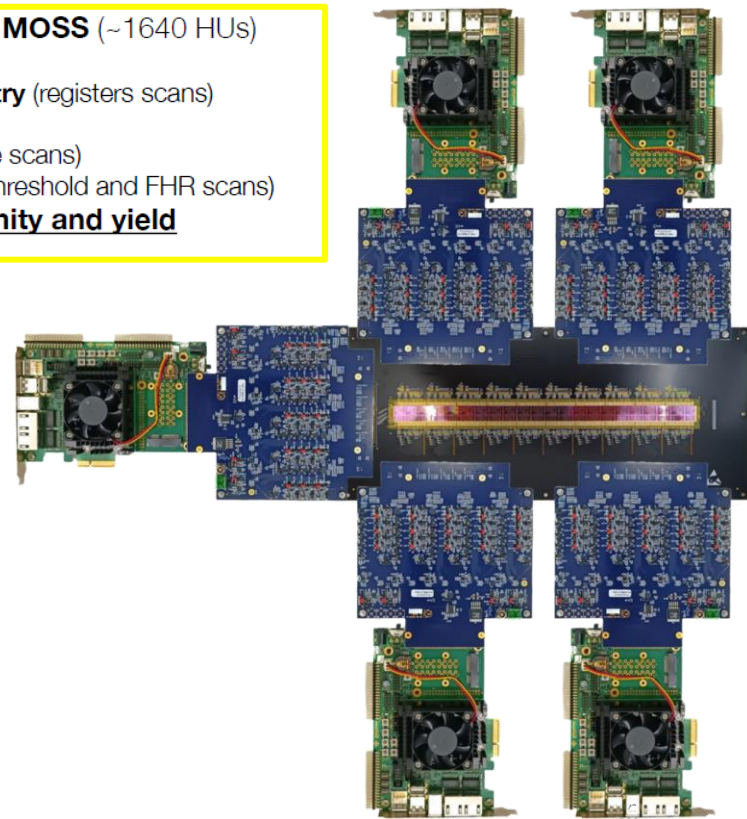
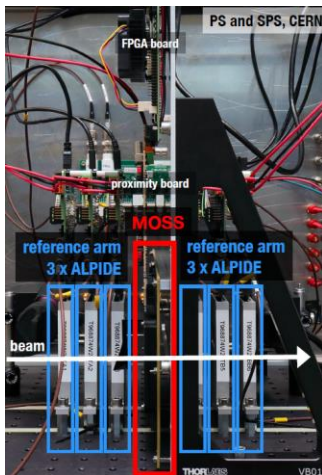
- ▶ detection efficiency and Fake-Hit Rate (FHR)

In **beam test**:

- ▶ detection efficiency and Fake-Hit Rate (FHR)
 - **~80 days of data-taking** last year on several sensors (~17)

Several functional tests on all **82 MOSS** (~1640 HUs)

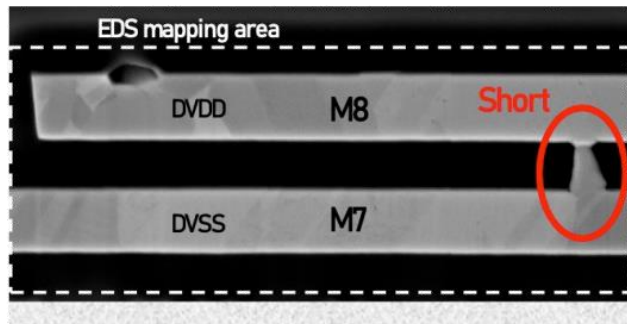
- ▶ **Power on** to check currents
 - ▶ **Slow control and digital circuitry** (registers scans)
 - ▶ **Analog biasing** (DAC scan)
 - ▶ **Matrix readout** (digital, analogue scans)
 - ▶ **Analog matrix performance** (threshold and FHR scans)
- to get **performance, uniformity and yield**



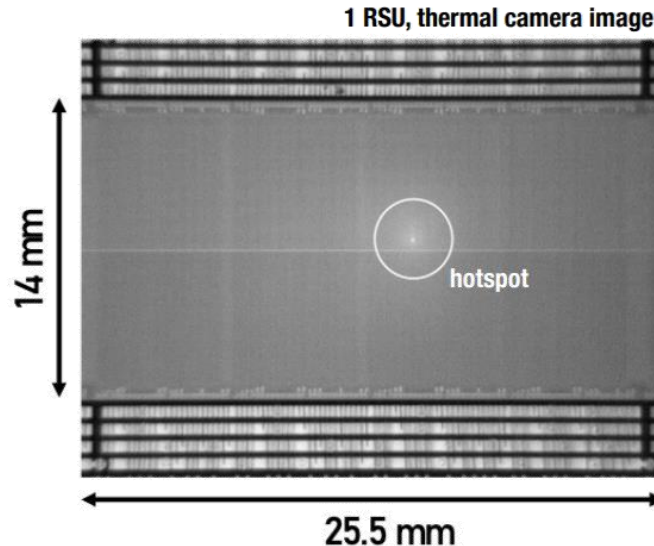
MOSS – power ramp

Large number of **shorts** observed during ramping:

- ▶ **Hotspot** appear
- ▶ Often they **disappear** (after some time or voltage)
- ▶ Position reconstructed O(50-100 μm)



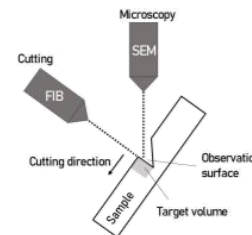
SEM (Scanning Electron Microscopy) cross section of the top two metal layers



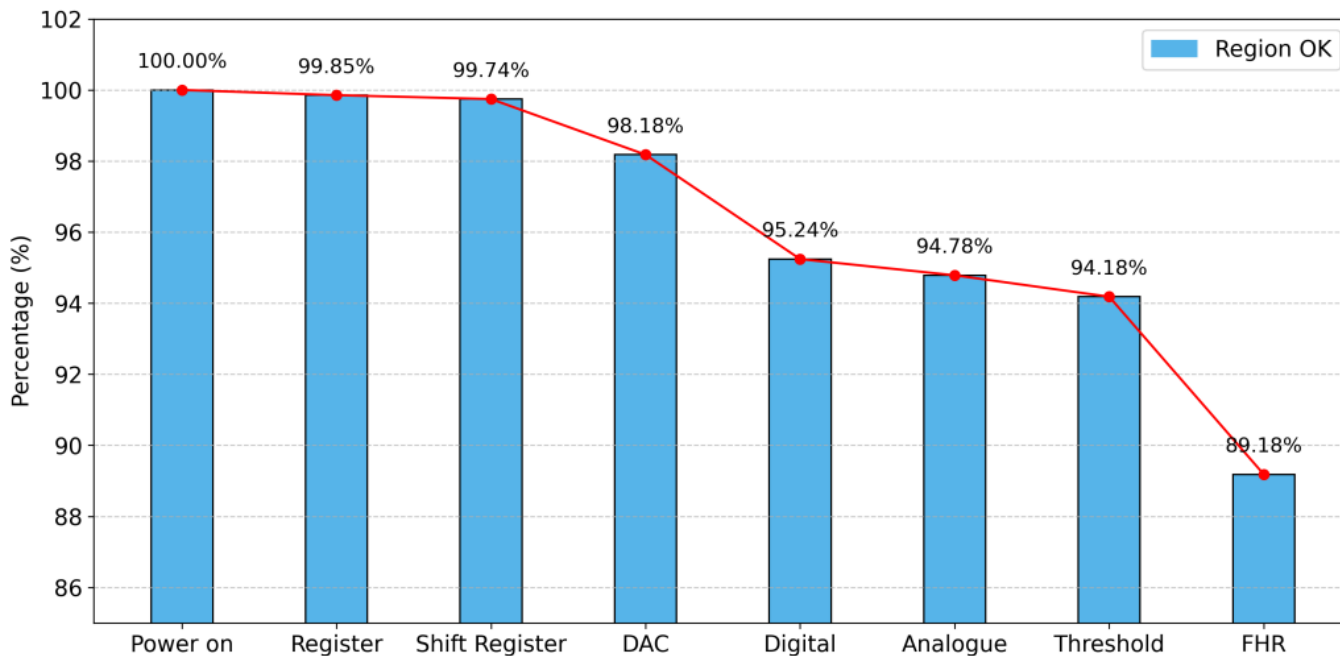
Reason **understood**:

- ▶ Correlated with crossing of metal lines on the top two metal
- ▶ Communicated to foundry that confirmed the issue → will be fixed for future sensors

→ **Very important finding for yield next submission!**

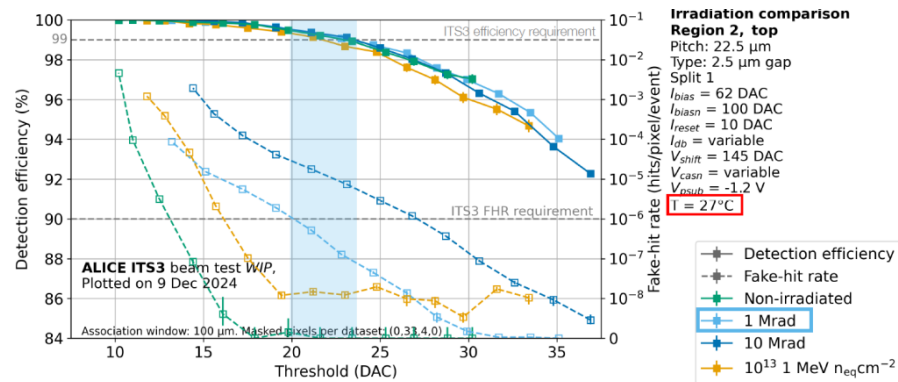
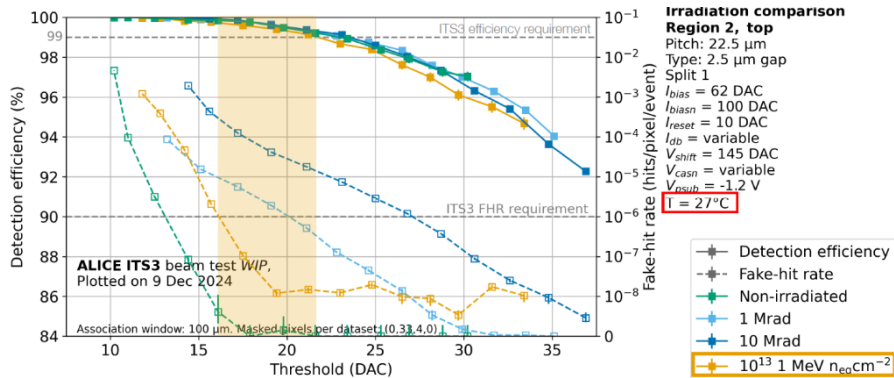
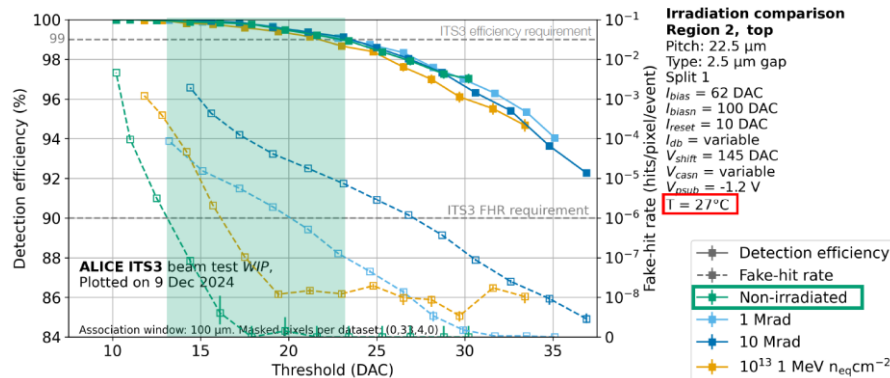


MOSS – Functional tests - Yield



- ▶ Yield ~ 89 %
 - ~98% excluding readout architecture issues (not relevant for future MOSAIX)

ER1 (Engineer Run 1): radiation tolerance studies

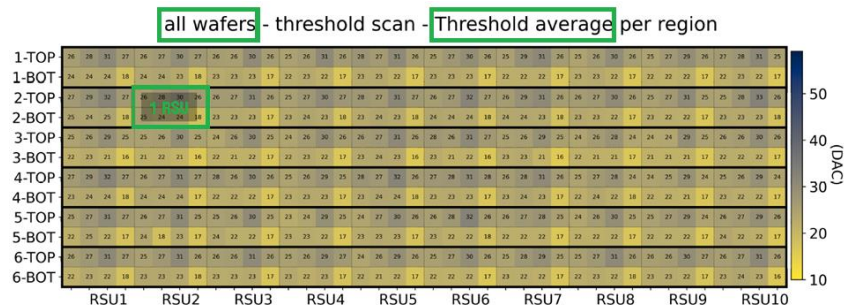


ER1 (Engineer Run 1): first stitched MAPS



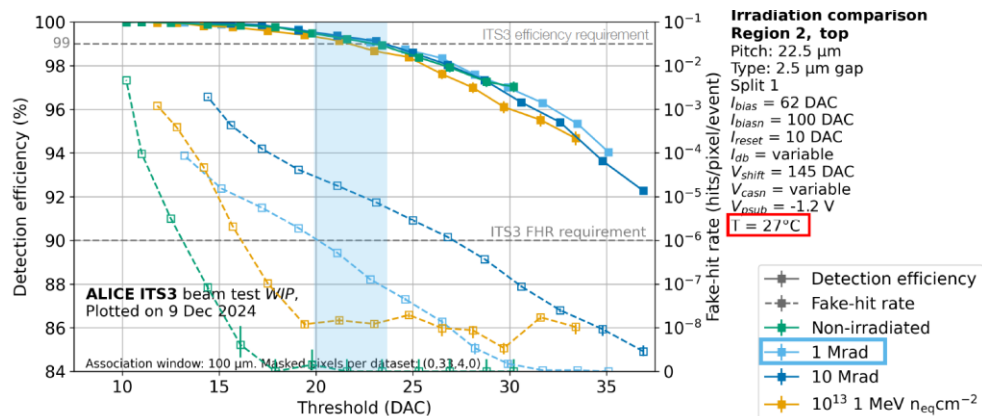
MOSS - functional tests

- Several functional tests on all 82 MOSS
 - Yield ~89 % (~98% excluding readout issues)
- Good performance and uniform behavior
 - NO wafer or sensor position dependence



Beam test results

- Operational margin à confirmed performance from previous submissions

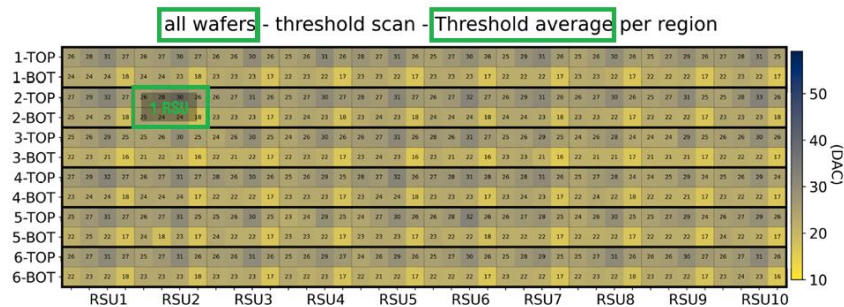


ER1 (Engineer Run 1): first stitched MAPS



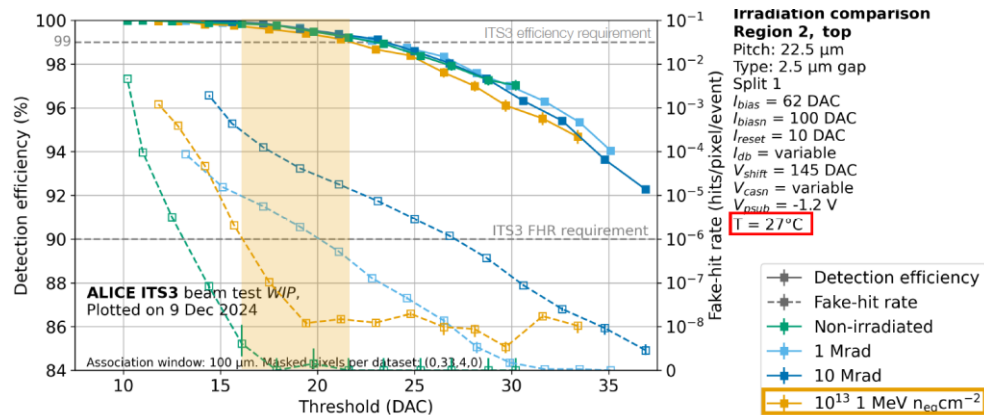
MOSS - functional tests

- Several functional tests on all 82 MOSS
 - Yield ~89 % (~98% excluding readout issues)
- Good performance and uniform behavior
 - NO wafer or sensor position dependence



Beam test results

- Operational margin à confirmed performance from previous submissions



ER2 - specification

Simulation parameters	Value	Unit	Conditions
Particle Rates			
Pb-Pb Interaction Rate	164	kHz	Safety factor 2
Particle flux (Hadronic)	2.55	MHz cm ⁻²	z=0 cm, all centralities.
Particle flux (QED)	3.20	MHz cm ⁻²	z=0 cm.
Total particle flux	5.75	MHz cm ⁻²	z=0 cm, all centralities.
Geometry, timing, encoding, data transfer capacity			
Pixel dimensions	20.8 × 22.8	μm × μm	
Tile pixel array size	442 × 156		
Pixels per Tile	68952		
Sensitive Area of the tile	0.328	cm ²	
Tiles per segment	144		
Readout regions per tile	3 or 4		
Frame Interval Duration (FD)	2 or 5	μs	
Minimum average cluster size	2.1		Δz = 0 cm, Fig. 3.43.
Pixel hit encoding time	25	ns	
Bits per pixel hit	16	bit	
Capacity of tile link	160	Mbit s ⁻¹	
Aggregated capacity (Segment)	23.04	Gbit s ⁻¹	
Simulation results			
Average pixel occupancy	< 2.0 × 10 ⁻⁴		z=0 cm.
Average pixel occupancy	< 5.0 × 10 ⁻⁴		z=0 cm, FD=5 μs.
Data throughput	120	Mbit s ⁻¹ Tile ⁻¹	z=0 cm.
Data throughput	15.55	Gbit s ⁻¹ Segment ⁻¹	
Data throughput per unit area	365	Mbit s ⁻¹ cm ⁻²	z=0 cm.
Data throughput per unit area	329	Mbit s ⁻¹ cm ⁻²	Average over z.
Data throughput per link	2.58	Gbit s ⁻¹	
Incomplete event probability	< 6 × 10 ⁻⁵		Layer 0 segment.
Incomplete event probability	< 2 × 10 ⁻⁴		Full layer 0.

ER2 – MOSAIX variants

144 power units, can be powered/tested independently

Per each RSU

- ▶ 12 different pixel variants to fine tune operational margins
 - 3 front-end circuit variation to improve S/N
 - 1 (antenna) to mitigate degradation with processing
 - 2 biasing variants, to reduce temperature sensitivity
- ▶ In addition → different splits to increase operational margin

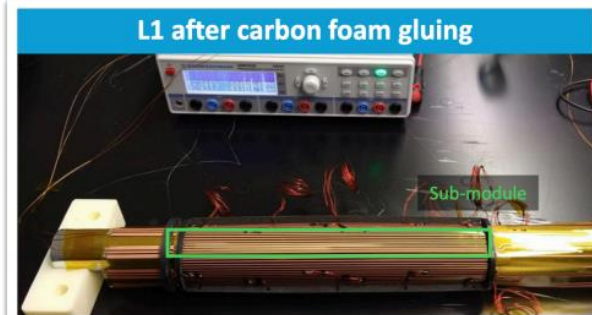
Baseline Biasing			RSU		
Small input (-40%), with diodes	Standard (Baseline), with diodes	Standard (Baseline)	Small Input and Longer VCASB transistor	Small Input (-40%) and Longer VCASB transistor, with diodes	Longer VCASB transistor, with diodes
Standard (Baseline)	Small input (-40%)	Longer VCASB (+150%)	Small Input and Longer VCASB transistor	Small Input (-40%) and Longer VCASB transistor, with diodes	Longer VCASB transistor, with diodes

Biasing with Temperature Compensation

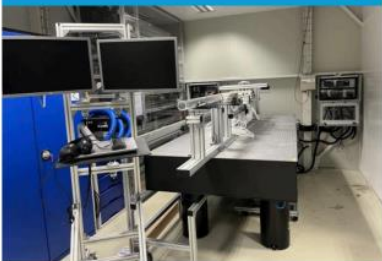
Qualification Model

At the half-layer level

Before integration, and after wire bonding and carbon foam gluing, individual electrical testing.



ALICE lab Bld.167 test rig



At the half-detector level

Thermal and aeroelastic assessment using the wind tunnel setup at the ALICE Mechanics Lab.

At the detector barrel level

Installation and final cooling strategy assessment (thermal & vibrational aspects) with QMs in the ALICE Cleanroom

